

Notice of References Cited	Application/Control No. 09/785,573	Applicant(s)/Patent Under Reexamination CREETH, RICHARD F.	
	Examiner Chongshan Chen	Art Unit 2172	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	C	US-6,539,398	03-2003	Hannan et al.	707/103R
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	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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